



1763#  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kouji TOMETSUKA

Serial No.: 09/911,741

Filed: July 25, 2001

For: SUBSTRATE PROCESSING APPARATUS AND METHOD

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:  
: Group Art Unit: 1763  
:  
: Examiner: R.N. Kackar  
:

#9  
4118103  
mw

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Applicants request that the period for response to the outstanding official action in this case be extended pursuant to 37 CFR 1.136 (a) for TWO (2) months to April 15, 2003.

The fee set in 37 CFR 1.17(a)(2) for a two month extension of time is \$410.00 and a check in this amount is submitted herewith. Please charge any additional fee required for this extension to Deposit Account No. 02-0200. A duplicate copy of this paper is attached.

Respectfully submitted,

BACON & THOMAS, PLLC

04/16/2003 ANABI1 00000101 09911741

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By: Richard E. Fichter  
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REF:kdd  
EXT-LRG.EX2.wpd

April 10, 2003

**GROUP 1700**

APR 18 2003

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